

Notice of References Cited	Application/Control No. 10/598,967		Applicant(s)/Patent Under Reexamination NAKAYOSHI ET AL.	
	Examiner Cathy Lam		Art Unit 1794	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,191,183 B1	02-2001	Kobayashi et al.	438/781
*	B	US-6,281,135 B1	08-2001	Han et al.	438/725
*	C	US-6,447,846 B2	09-2002	Nakamura et al.	427/387
*	D	US-6,551,676 B1	04-2003	Yamakawa et al.	428/40.1
*	E	US-7,074,849 B2	07-2006	Nakayoshi et al.	524/588
*	F	US-7,417,373 B2	08-2008	Yamazaki, Shunpei	313/506
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
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	X	

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